

[10191/1808]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Franz LAERMER et al.
Serial No. : 09/889,838
Filed : January 24, 2002
For : PLASMA ETCHING METHOD HAVING PULSED
SUBSTRATE ELECTRODE POWER
Examiner : Allan Olsen
Art Unit : 1763
Confirmation No. : 1541

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Dec. 12, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT

SIR:

In response to the Office Action of July 30, 2003, kindly amend the
above-captioned application as follows:

Amendments to the Claims are reflected in the listing of claims,
which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.

NY01 630715

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